

=> d his

STN USPAT

(FILE 'USPATFULL' ENTERED AT 12:48:35 ON 24 SEP 2001)

DEL HIS

L1 191 S (CMP OR ?POLISH? OR LAP OR GRIND## OR ABRAD### OR PLANARIZ?)
L2 36 S L1(P)(WAFER# OR CHIP# OR SEMICONDUCT#)
L3 86 S L1(P)(VAP? OR GAS? OR HEAT? OR FILTER?)
L4 115 S L1(P)(END? OR STOP? OR MONITOR? OR DETECT? OR DETERMIN? OR ME
L5 152 S L2 OR L3 OR L4
L6 191 S L1 OR L5
 DEL POLISHL19/A
 DEL POLISHL31/A
 SAVE POLISHL6/A L6

=>

=> d his

STN, Cas, Japis

(FILE 'HOME' ENTERED AT 12:06:20 ON 24 SEP 2001)

FILE 'CA' ENTERED AT 12:06:42 ON 24 SEP 2001
L1 1140 S (CMP OR POLISH? OR CHEMIPOLISH? OR CHEMIMECH? OR PLANARIZ? OR
L2 508 S (CMP OR POLISH? OR CHEMIPOLISH? OR CHEMIMECH? OR PLANARIZ? OR
L3 1639 S L1 OF L2
L4 114 S L3 AND (WAFER? OR CHIP# OR SEMICONDUCT?)
L5 38 S L3 AND FILTER?
L6 1 S L4 AND L5
L7 80 S (L4 OR L5) AND (MASS?(3A)SPEC?)
L8 1525 S L3 NOT L4
L9 728 S L8 AND (MASS?(3A)SPEC?)
L10 97 S L9 AND (CMP OR POLISH? OR CHEMIPOLISH? OR CHEMIMECH? OR PLANA
SAVE POLISHL5/A L5
SAVE POLISHL10/A L10
L11 792 S L3 AND (MASS?(3A)SPEC?)
L12 619 S L11 NOT (L7 OR L10)
DEL PLASMAL18/A
SAVE POLISHL12/A L12

=>